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MAILSTOP AMENDMENT



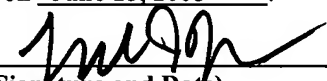
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Syunji HASUO, et al.  
Serial No. : 10/657,337  
Filed : September 8, 2003  
For : ANODIZATION-ADAPTED ALUMINUM ALLOY AND  
PLASMA-TREATING APPARATUS MADE THEREOF  
Group Art Unit : 1775  
Examiner : Jennifer C. McNeil

**Certificate of Mailing Under 37 CFR 1.8**

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Frank J. Jordan  
(Name)

 06/15/05  
(Signature and Date)

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**INFORMATION DISCLOSURE STATEMENT**


Sir:

Attached hereto is a copy of Japanese Official Action dated March 28, 2005, a copy of Form PTO-1449 and copies of the five references listed therein.

Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Information Disclosure Statement. Thus this Information Disclosure Statement is being filed within three months of the date March 28, 2005 of the Japanese Search Report in the counterpart foreign application. Accordingly, no PTO charge is believed necessary. However, if there is any PTO charge for filing this IDS , please charge to Deposit Account No. 10-1250.

Respectfully submitted,

Jordan and Hamburg LLP

By 

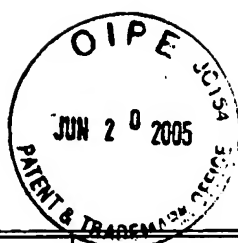
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F-7951

<b>Form PTO-1449</b> (Rev. 7-80) 42-44F (F-49)		<b>U.S. Department of Commerce</b> <b>Patent and Trademark Office</b>		<b>Atty. Docket No.: F-7951</b>		<b>Serial No.: 10/657,337</b>	
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				<b>Applicant: Syunji HASUO, et al.</b>			
				<b>Filing Date: September 8, 2003</b>		<b>Group: 1775</b>	
<b>U.S. PATENT DOCUMENTS</b>							
<b>Examiner Initial</b>		<b>Document Number</b>	<b>Date</b>	<b>Name</b>	<b>Class</b>	<b>Subclass</b>	<b>Filing Date if Appropriate</b>
<b>FOREIGN PATENT DOCUMENTS</b>							
		<b>Document Number</b>	<b>Date</b>	<b>Country</b>	<b>Class</b>	<b>Subclass</b>	<b>Translation</b>
							<b>Yes</b> <b>No</b>
		9-217197	8/19/1997	JP			Y*
		2000-313996	11/14/2000	JP			Y*
		8-269599	10/15/1996	JP			Y*
		8-311593	11/26/1996	JP			Y*
		10-226857	8/25/1998	JP			Y*
<b>TRANSLATION KEY:</b> * English Abstract. <sup>F</sup> Concise statement of relevance provided in foreign search report. <sup>C</sup> Concise statement of relevance provided in specification. <sup>S</sup> Concise statement of relevance provided in IDS. <sup>P</sup> Relevant portion of reference translated. <sup>O</sup> English abstract only - copy of reference in pct search.							
<b>OTHER INFORMATION DISCLOSURE CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
<b>EXAMINER</b> Jennifer C. McNeil					<b>DATE CONSIDERED</b>		
<b>EXAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							